

200 ↗

Figure 1

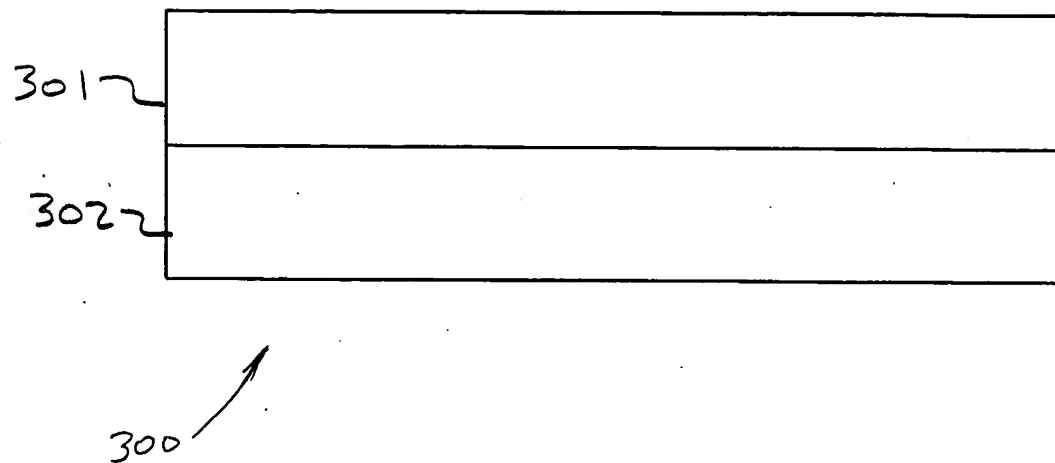


Figure 2

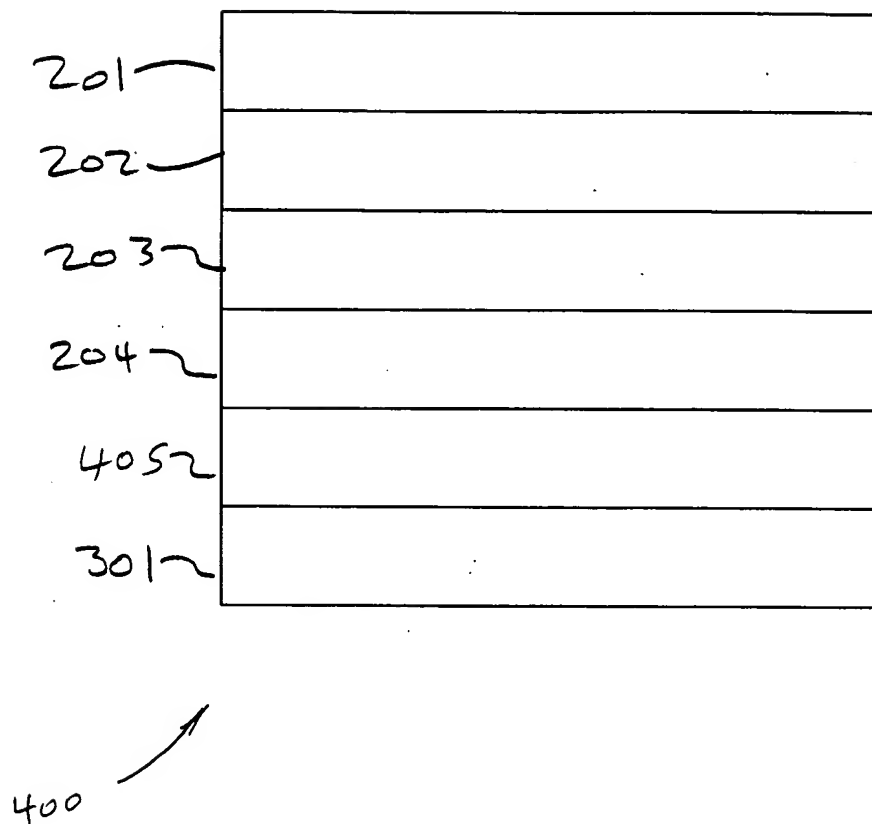


Figure 3

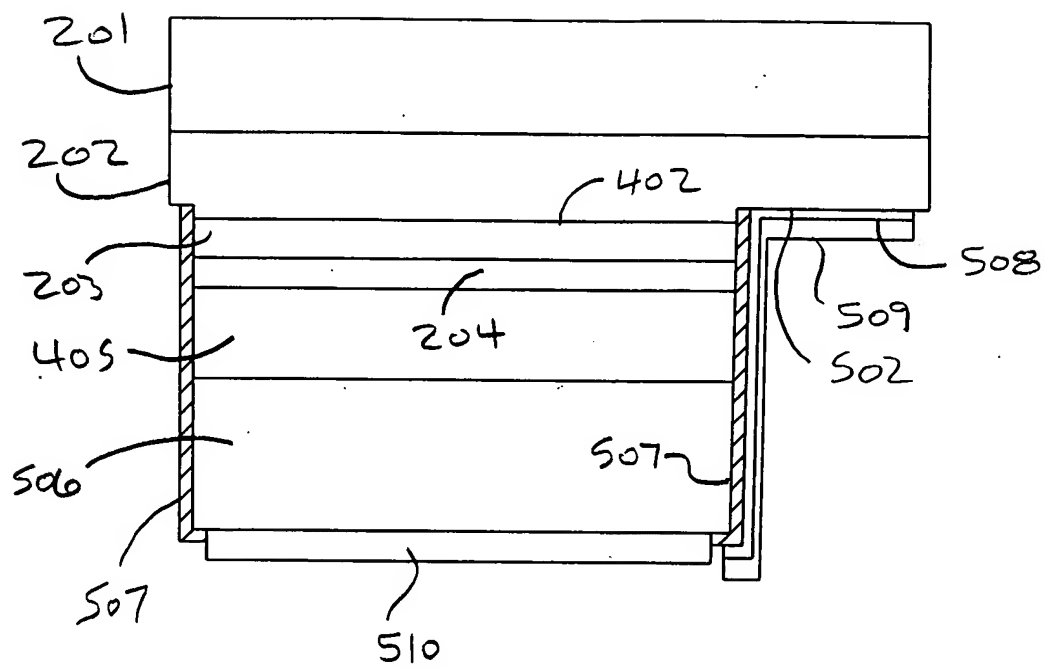


Figure 4

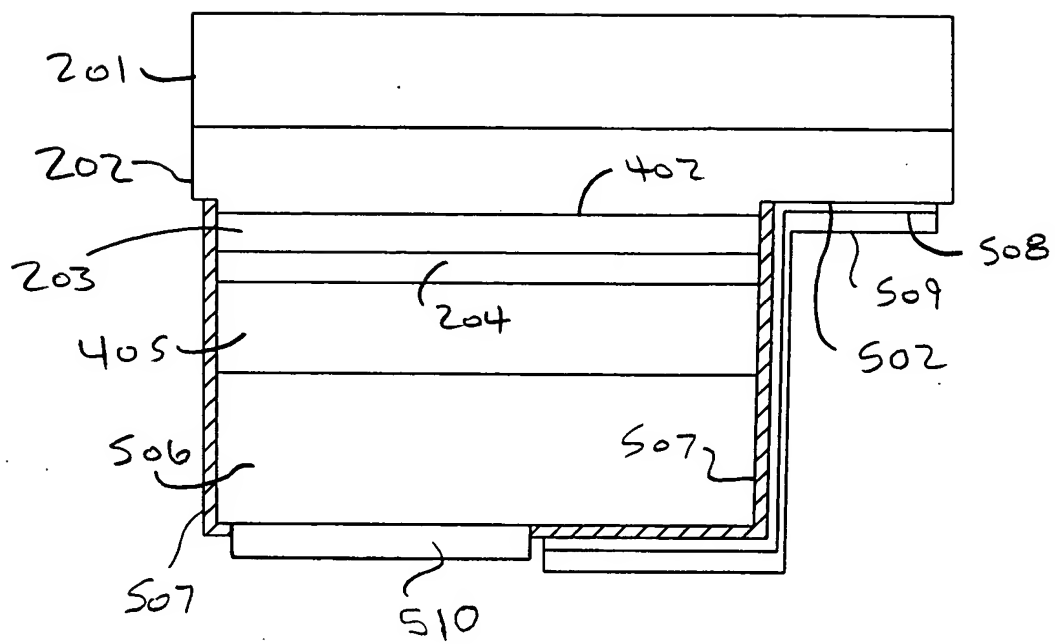


Figure 5

Wafer Process Flow for GaN wafer Bonding

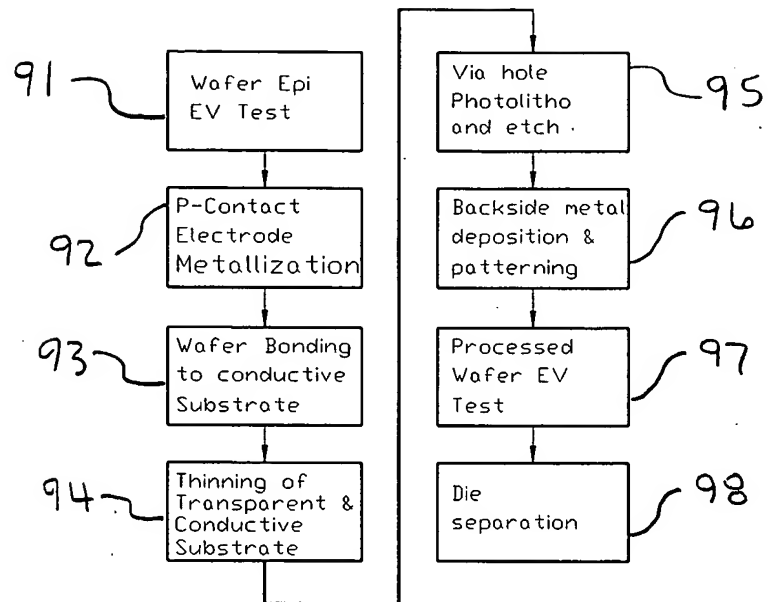
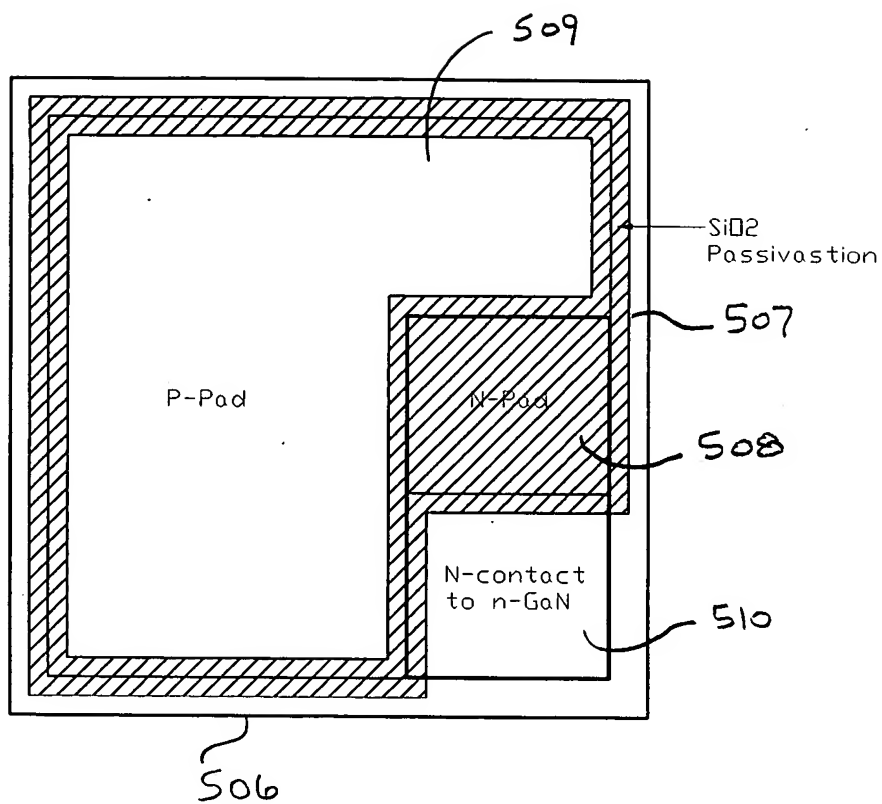


Figure 6



400 ↗

Figure 7